



9-1-04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/609,311
Filing Date June 26, 2003
Inventor Donald L. Yates
Assignee Micron Technology, Inc.
Group Art Unit 2811
Examiner Unknown
Attorney Docket No. MI22-2236
Customer No. 021567
Title: Semiconductor Processing Patterning Methods and Constructions

INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Copies of all references are attached. No admission is made regarding whether all the listed references are prior art.

Citation of the referenced art is respectfully requested.

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Respectfully submitted,

Dated: 8/30/04

By:



Robert C. Hyta
Reg. No. 46,791



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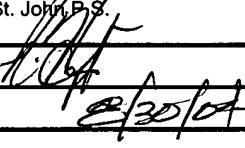
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Total Number of Pages in This Submission	Application Number	10/609,311
	Filing Date	June 26, 2003
	First Named Inventor	Donald L. Yates
	Art Unit	2811
	Examiner Name	Unknown
	Attorney Docket Number	MI22-2236

ENCLOSURES (Check all that apply)

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Firm or Individual name	Robert C. Hyta/Reg. No. 46,791 Wells St. John, P.S.
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Form PTO-1449 <i>O I P E</i> AUG 3 0 2004 <i>SC 16</i> <i>SEARCHED</i> <i>INDEXED</i> <i>MAILED</i>	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)	ATTY. DOCKET NO. MI22-2236	SERIAL NO. 10/609,311
		APPLICANT: Donald L. Yates	
		FILING DATE June 26, 2003	GROUP 2811

U.S. PATENT DOCUMENTS

*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,086,074	04/78	Minot et al.			
	AB	4,622,735	11/86	Shibata			
	AC	4,683,645	08/87	Naguib et al.			
	AD	4,693,910	09/87	Nakajima et al.			
	AE	4,766,090	08/88	Coquin et al.			
	AF	5,099,304	03/92	Takemura et al.			
	AG	5,236,865	08/93	Sandhu et al.			
	AH	5,444,024	08/95	Anjum et al.			
	AI	5,470,784	11/95	Anjum et al.			

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AM	ABSTRACT: Basceri et al., Atomic Layer Deposition for Nanoscale CU Metalization, 10 pages (pre-April 2004).
	AN	En et al., Plasma immersion ion implantation reactor design considerations for oxide charging, 85 SURFACE AND COATINGS TECHNOLOGY 64-69 (1966).
	AO	Ku et al., The Application of Ion Beam Mixing, Doped Silicide, and Rapid Thermal Processing of Self-Aligned Silicide Technology, 137 J. Electrochem. Soc. No. 2, pp. 728-740 (February 1990).

EXAMINER DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,670,298	09/97	Hur			
	AB	6,037,239	03/00	Jennings			
	AC	6,096,621	08/00	Jennings			
	AD	6,130,140	10/00	Gonzalez			
	AE	6,133,105	10/00	Chen et al.			
	AF	6,133,116	10/00	Kim et al.			
	AG	6,156,674	12/00	Li et al.			
	AH	6,177,235 B1	01/01	Francou et al.			
	AI	6,281,100 B1	08/01	Yin et al.			

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		Document Number	Date	Country	Class	Subclass	Translation
							Yes
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AM	ABSTRACT: How to Eliminate Voiding in Porous-Low-k Dielectrics and The Mechanism of Void Formation; Lin et al.; 4 pages	
	AN	COB Stack DRAM Cell Technology beyond 100 nm Technology Node; Yongjik Park & Kinam Kim; pp. 349.1 - 349.3;	
	AO	Rubin et al., Shallow-Junction Diode Formation by implantation of Arsenic and Boron Through Titanium-Silicide Films and ..., 17 IEEE Transactions on Electron Devices, No. 1, pp. 183-190 (January 1990).	
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	AA	6,277,709 B1	08/01	Wang et al.					
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	AD	6,380,611 B1	04/02	Yin et al.					
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	AG	6,465,325 B2	10/02	Ridley et al.					
	AH	6,720,638 B2	04/04	Tran					
	AI	6,780,728	08/04	Tran					
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	AJ							Yes	No
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	AA	2001/0006759 A1	07/01	Shipley, Jr. et al.					
	AB	2002/0076879 A1	06/02	Lee et al.					
	AC	2002/0196651 A1	12/02	Weis					
	AD	2003/0013272 A1	01/03	Hong et al.					
	AE								
	AF								
	AG								
	AH								
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	AA	10/655,997		Daley				09/03	
	AB	10/689,958		Basceri				10/03	
	AC	10/690,029		Derderian et al.				10/03	
	AD	10/882,118		Sandhu et al.				04/04	
	AE	10/879,367		Blalock et al.				06/04	
	AF								
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	AH								
	AI								
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